

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 7,247,900 B2  
APPLICATION NO. : 10/631858  
DATED : July 24, 2007  
INVENTOR(S) : Honma et al.

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title Page, item 56, under "References Cited" section, other References  
--Item I "Low Temperature Deposition Material"  
Section 4 "New Deposition Material"  
Ferroelectric Memory Advanced Process  
September 13, 1999-- should be added

Signed and Sealed this

Twenty-third Day of February, 2010

A handwritten signature in black ink that reads "David J. Kappos". The signature is written in a cursive, flowing style.

David J. Kappos  
*Director of the United States Patent and Trademark Office*